Special Issue

NANO KOREA 2018

Message from the Guest Editors

This Special Issue will publish selected papers from the 16th International Nanotech Symposium & Nano-Convergence Exhibition (NANO KOREA 2018), 11–13 July, 2018, Goyang, Korea. In particular, the symposium, the largest sympoisum on nanoscale science and technology in Korea, will be a meaningful occasion to confirm major research results and up-to-date research trends, increase the exchange among researchers in relevant fields, and materialize the results of research. The NANO KOREA symposium will cover the following main topics:

- Nanoelectronics and photonics
- Advanced Nanomaterials
- Nanofabrication and Measurement
- Nanobiotechnology and Nanomedicine
- Nanotechnology for Energy
- Safety, Standardization and Regulation in Nanotechlogy
- Sensors and Actuators
- Computational Nano Science and Technology

Papers attracting the most interest at the conference, or that provide novel contributions, will be selected for publication in Micromachines. These papers will be peer-reviewed for validation of research results, developments and applications.

Guest Editors

Prof. Dr. Dae Joon Kang

Prof. Dr. Kyoung Jin Choi

Prof. Dr. Junhong Min

Prof. Dr. Wan Soo Yun

Prof. Dr. Jong-Ryul Jeong

Deadline for manuscript submissions

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You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Editor-in-Chief

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